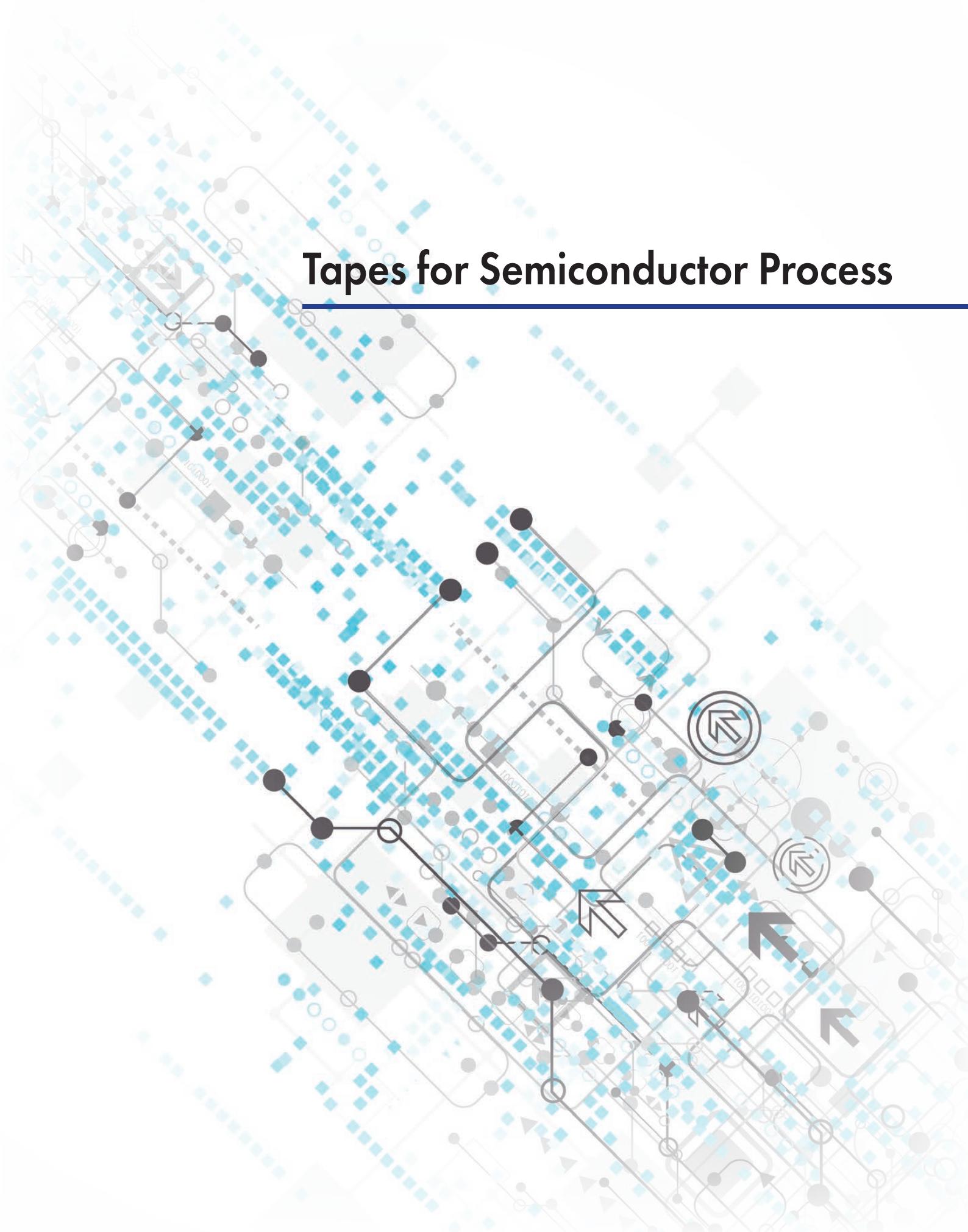
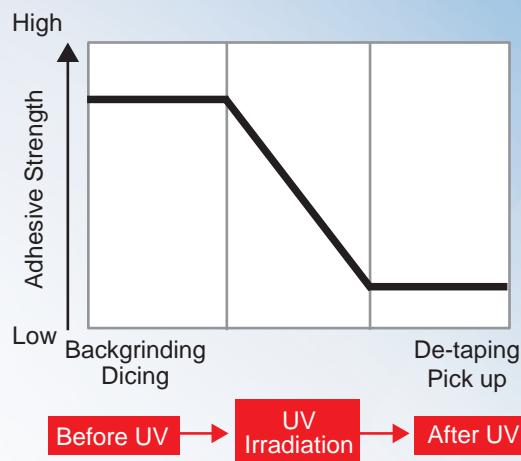


Tapes for Semiconductor Process



What is UV Tape ?

UV Tape is adhesive tape for semiconductor process. It is suitable to protect surface of semiconductor wafer during backgrinding process, and to hold semiconductor wafer with ring frame during dicing process. It is also applicable for various workpieces such as ceramics, glass, sapphire and so on.

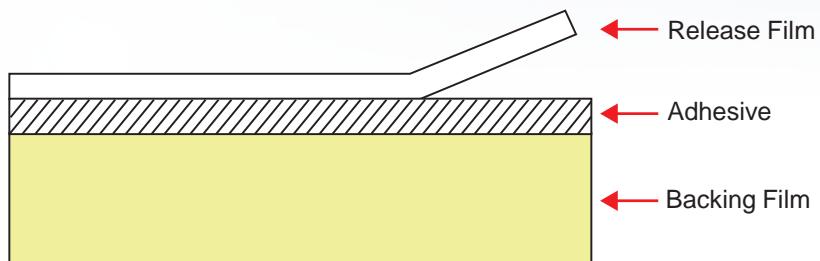


The advantage of UV tape

UV tape has stronger adhesive strength and can hold wafer firmly in backgrinding process or dicing process. After UV irradiation, adhesive strength decreases drastically and easy de-taping or die pick up can be achieved.

Structure

Tape consists of backing film and adhesive layer, and the surface of the adhesive layer is covered with a release film. Backing film, adhesive layer, and release film are mainly made of polyolefin, acrylic adhesive and PET, respectively.



Process	Backgrinding		Dicing		
	Tape	SP Series	CP Series	UC Series	FC Series
Features	UV Type	Non-UV Type	UV Type	UV Type	UV Type
Release Film	PET	PET Polypropylene	PET	PET	PET
Adhesive	Acrylic	Acrylic	Acrylic	Acrylic	Acrylic
Backing Film	Polyolefin	Polyolefin	Polyolefin	Polyolefin	Polyolefin

* Data shown in this brochure are typical values and not guaranteed values.

* For any other special application, please contact our representatives.

SP Series

CP Series



■ SP Series UV Tape for Wafer Backgrinding

- SP series is designed for surface protection of semiconductor wafer during backgrinding process.
- Easily de-taped from wafer without stress after UV irradiation.

Tape		SP-594M-130	SP-541B-205	SP5156B-130	SP-537T-230
Backing Film Thickness(μm)		100	165	110	100
Adhesive Strength (N/25mm)	#280-SUS	Before UV After UV	8.6 0.1	2.7 0.5	1.4 0.4
	Si-Wafer	Before UV After UV	3.3 0.1	1.6 0.2	0.6 0.1
Tensile Strength (N/10mm)	MD	23	26	21	21
	TD	22	23	17	18
Elongation (%)	MD	800	430	450	570
	TD	930	570	620	730
Features		• Standard • Etching Durable	• Low Warpage • For Thin Wafer	• Low Warpage • For Thin Wafer	• For Bumped Wafer

■ CP Series Non-UV Tape for Wafer Backgrinding

- CP series is designed for surface protection of semiconductor wafer during backgrinding process.
- Easily de-taped from wafer without stress by optimized adhesive strength.

Tape		CP9007B-130	CP9003B-205B	CP9079B-200
Backing Film Thickness(μm)		100	165	165
Adhesive Strength (N/25mm)	#280-SUS	0.9	1.8	0.6
	Si-Wafer	0.7	1.6	0.4
Tensile Strength (N/10mm)	MD	21	44	34
	TD	19	34	36
Elongation (%)	MD	550	600	500
	TD	710	710	690
Features		• Standard	• Surface Roughness Absorption(<20μm) • Low Warpage • For Thin Wafer • Acid Etching Durable	• Silicone Free Release Film(No release agent)

UC Series

FC Series



■ UC Series UV Tape for Wafer Dicing

- UC series is designed to hold semiconductor wafer with ring frame, during dicing process.
- Easy die pick up without stress after UV irradiation.

Tape		UC-353EP-110A	UC3026M-110	UC3044M-110B	UC-334EP-85
Backing Film Thickness(μm)		100	100	100	80
Adhesive Thickness(μm)		10	10	10	5
Adhesive Strength (N/25mm)	#280-SUS	Before UV	7.1	5.0	2.7
		After UV	0.4	0.5	0.2
Si-Wafer	Before UV	2.7	1.6	1.2	1.1
	After UV	0.1	0.1	0.1	0.2
Tensile Strength (N/10mm)	MD	49	26	41	22
	TD	44	26	39	18
Elongation (%)	MD	750	310	740	360
	TD	820	410	800	520
Features		• Standard • For Thick Wafer	• For Die Separation By Expansion	• For In-Line Process • For Thin Wafer	• For Metallized Wafer

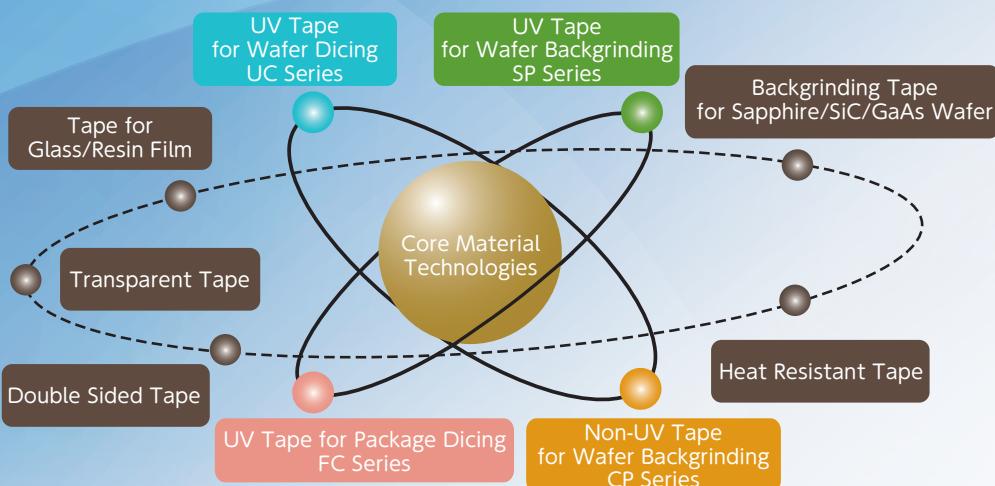
■ FC Series UV Tape for Package Dicing

- Optimized tackiness holds packages during dicing process.
- Easy die pick up for BGA, QFN, and other package types, after UV irradiation.

Tape		FC-217M-170	FC-224M-170	FC2143M-165	FS-8304-170
Backing Film Thickness(μm)		150	150	150	150
Adhesive Thickness(μm)		20	20	15	20
Adhesive Strength (N/25mm)	#280-SUS	Before UV	6.7	6.2	9.8
		After UV	0.4	0.4	0.2
Si-Wafer	Before UV	6.6	4.8	7.3	5.5
	After UV	0.3	0.3	0.1	0.3
Adhesive Strength (N/10mm)	PKG	Before UV	0.5	0.6	1.3
		After UV	0.1	0.1	0.1
Tensile Strength (N/10mm)	MD	34	44	63	48
	TD	32	42	60	46
Elongation (%)	MD	790	340	780	650
	TD	920	400	820	680
Features		• Standard	• Burr Suppressed Backing Film	• For Small Package	• Anti-ESD Before UV:9E+10 After UV:5E+11

UV Tape for Special Application

UV Tape for Special Application



Tape			UC3160M-95	UC3145M-170	UC3166M-115	UC3098M-110
Backing Film Thickness(μm)			80	150	100	100
Adhesive Thickness(μm)			15	20	15	10
Adhesive Strength (N/25mm)	#280-SUS	Before UV	1.8	11.4	8.1	6.1
	#280-SUS	After UV	0.3	0.4	0.3	0.4
	Si-Wafer	Before UV	0.5	10.4	7.7	2.5
Glass	Si-Wafer	After UV	0.1	0.1	0.2	0.1
	Glass	Before UV	0.5	8.1	7.1	2.3
Features	<ul style="list-style-type: none"> For Glass Chip Separation By Expansion For Glass Chip Carrier 		<ul style="list-style-type: none"> For Glass Blade Dicing 	<ul style="list-style-type: none"> For Glass Chip Carrier/Cleaning 	<ul style="list-style-type: none"> For Glass/Resin Film Blade Dicing 	

Tape			UC3162T-120	UC-228W-110	SP-537T-130	SP6101T-40
Backing Film Thickness(μm)			100	70	100	25
Adhesive Thickness(μm)			20	20+20	30	15
Adhesive Strength (N/25mm)	#280-SUS	Before UV	4.4	11	4.1	1.4
	#280-SUS	After UV	0.2	0.2	1.6	0.1
Glass	Si-Wafer	Before UV	2.2	3.3	1.7	0.9
	Si-Wafer	After UV	0.1	0.1	0.1	0.1
Features		<ul style="list-style-type: none"> Transparent For Laser Dicing/ Marking Through Tape 	<ul style="list-style-type: none"> Double Sided 	<ul style="list-style-type: none"> For Sapphire/ SiC/GaAs Wafer Backgrinding 	<ul style="list-style-type: none"> Heat Resistant For Sputter 	

【Adhesive Strength Test Conditions】

Substrate : Mirror-Polished Silicon Wafer(Si-Wafer),
#280-Polished Stainless Steel Plate(#280-SUS),
Package(PKG), Glass

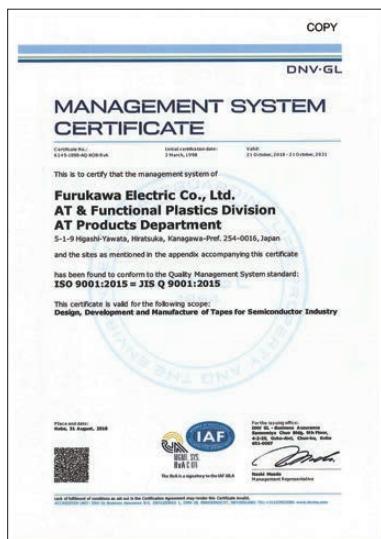
Peeling Angle : 90° Peeling Speed : 50mm/min (SP, UC, FC Series)

Peeling Angle : 180° Peeling Speed : 300mm/min (CP Series)

【Tensile Strength/Elongation Test Conditions】

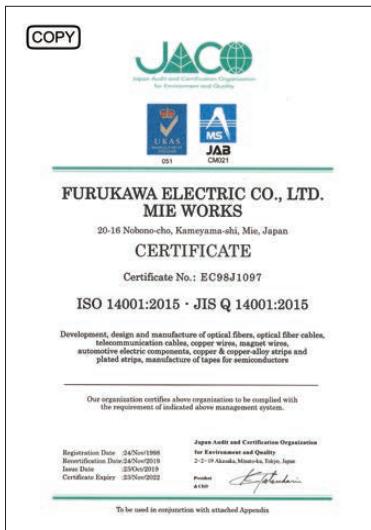
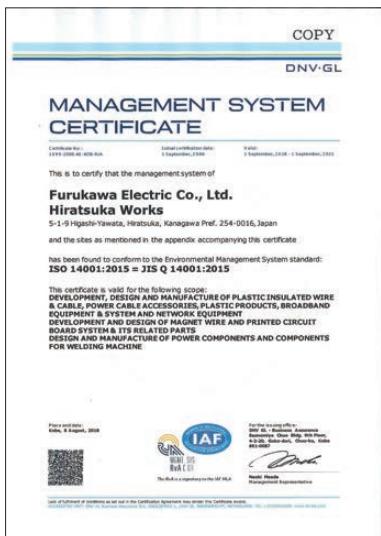
Sampling : Before UV Stretching Speed : 300mm/min
MD : Machine Direction TD : Transvers Direction

ISO 9001 Certification



Furukawa Electric has acquired the ISO 9001 certification for Global Quality Management System about design, development and manufacture of tapes for semiconductor process.

ISO 14001 Certification



Hiratsuka Works, Mie Works

Furukawa Electric recognizes that preservation of the global environment is a critical issue for society, and shall incorporate consideration of environmental preservation issues into every phase of corporate activity, to contribute forwards the sustainable development of prosperous and bright society.

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